

Attorney Docket No.: 0180192

REMARKS

Prior to the present response, claims 1-2, 4-9, and 11-14 were pending in the present application, and remain pending after the present response. Reconsideration and allowance of pending claims 1-2, 4-9, and 11-14 in light of the following remarks are respectfully requested.

A. Rejections of Claims 1-6 and 8-13 Under 35 USC § 102(b) and Claims 7 and 14 Under 35 USC § 103(a)

The Examiner has rejected claims 1-6 and 8-13 under 35 USC § 102(b) as being anticipated by U.S. Patent 6,147,379 to Hori (hereinafter "Hori") "in view of" U.S. Patent 6,721,205 to Kobayashi (hereinafter "Kobayashi"). The Examiner has separately rejected claims 7 and 14 under 35 USC § 103(a) as being unpatentable over Hori in view of Kobayashi. For the following reasons, Applicant respectfully submits that the pending claims are patentably distinguishable over the cited art.

The present invention, as defined by the amended claims, defines a floating gate memory cell where a "Vss connection region" under a recess and under a source of the floating gate memory cell is heavily doped so as to dramatically reduce the "Vss resistance," i.e. the resistance present in ground interconnection feeding common source areas in a memory array. In the absence of the present invention, the Vss resistance results in significant voltage drop and power consumption and drastically impairs the performance of the memory array.

Moreover, the invention's floating gate memory cell with a Vss connection region under a recess and under a source of the floating gate memory cell, where the Vss connection regions is heavily doped, also prevents an increase in the pernicious DIBL (drain induced barrier lowering) problem. In the absence of the present invention, an increase in the source region doping level to achieve a lower Vss resistance would automatically worsen the DIBL problem.

Applicant respectfully submits that the structure of Hori does not teach, disclose, or even suggest the advantageous structure of the present invention as claimed by the amended claims. Moreover, Hori certainly is not directed to, nor does it achieve the advantages of the present invention embodied in the amended claims. Hori is directed to increasing electron injection efficiency in performing write operations, improving erase operations when taking out electrons from the floating gate into the drain region, suppressing the injection of holes into the oxide film when data is erased, increasing read current, and suppressing the degradation of the read disturb margin. See, for example, column 7, lines 5 through 20 of Hori. Among its long list of goals and achievements, Hori does not mention a word about lowering ground resistance (or Vss resistance) in the memory array. Nor does Hori mention a word about the harmful DIBL effects, to which the present invention is directed.

Applicant notes that the Examiner has acknowledged that Hori does not address lowering ground resistance (i.e. lowering Vss resistance) in the source region, since the Examiner has relied on Kobayashi as teaching "that Vss connection region is the source

of the memory cell through which the reference voltage is applied during the operation of the memory cell in column 19, lines 49-63.” Page 3 of the present Office Action, second paragraph. However, the Examiner has relied on a purported combination of Hori and Kobayashi under 35 USC § 102(b). Applicant submits that 35 USC § 102(b) cannot be used to reject a claim when a combination of two references, instead of a single reference, is relied upon. Assuming that the Examiner mistakenly cited 35 USC § 102(b) while intending to cite 35 USC § 103(a), the Examiner has not provided any arguments why and how the two references, i.e. Hori and Kobayashi, could be combined to achieve the present invention. Applicant submits that Kobayashi is directed to the operation of a memory device without any reference as to a need to reduce DIBL, or the need to reduce the ground resistance, or the need to reduce DIBL while also achieving a reduced ground resistance. As such, Kobayashi cannot be combined with Hori, since there is no motivation or suggestion in Kobayashi (or in Hori) to combine one with the other to achieve the present invention. Thus, since the Examiner has acknowledged that Hori does not address lowering ground resistance (i.e. lowering Vss resistance) in the source region, Hori lacks a key feature of the present invention.

Moreover, as noted in Applicant’s response to the previous Non-Final Office Action, in describing its Figure 1A (the Figure to which the Examiner has referred), Hori acknowledges that: “The nonvolatile semiconductor memory device shown in FIGS. 1A and 1B is *principally characterized* in (1) that the drain region 8 has a triple structure consisting of the high-concentration drain region 8a, the low-concentration drain region

8b and the extremely-low-concentration drain region 8c, (2) that the low-concentration drain region 8b is formed so as to cover the corner portion at the bottom of the step, (3) that the extremely-low-concentration drain region 8c is formed in the step side region 13 and (4) that the steps have been formed in accordance with an epitaxial growth.” Column 11, lines 5-14 of Hori (emphasis added).

Thus, in achieving its write/erase objectives discussed above, Hori focuses on the configuration of the drain region used for writing and erasing data (and not the source region used for providing a ground connection). In this regard, Hori states:

“Since this device has such a drain structure, when a voltage of about 5 V is applied to the drain region 8 in writing data, the extremely-low-concentration drain region 8c is depleted. In this case, since the low-concentration drain region 8b has a higher impurity concentration than that of the extremely-low-concentration drain region 8c, only a part of the low-concentration drain region 8b (i.e., a part adjacent to the extremely-low-concentration drain region 8c) is depleted. *As a result, a high electric field is formed in the corner portion between the second surface region 12 and the step side region 13*” Column 11, lines 15-25 of Hori (emphasis added). Thus, Hori in fact teaches away from reducing the DIBL problem which requires a lowering of, and not increasing, the electric field adjacent to the drain.

With reference to Figure 1A, Hori does state that: “The source region 7 formed in the first surface region 11 and the third surface region 14 includes a high-concentration impurity layer 7a and a low-concentration impurity layer 7b having an impurity

Attorney Docket No.: 0180192

concentration lower than that of the high-concentration impurity layer 7a.” Hori, column 9, line 64 through column 10, line 1. However, as clearly shown in Figure 1B (which is the top view of Figure 1A), the region covered by layer 7a includes the “relatively high level (a first surface region 11)” (See Hori, column 8, lines 50-51). In other words, a substantial portion of Hori’s “Vss connection region” is at the same elevation level as Hori’s “source 7b.” Therefore, in Hori, the Vss connection region is not under the source region, as required by the present invention. Thus, not only Hori fails to address the goals of the present invention, but also the invention’s structure, as claimed by independent claims 1 and 8, is patentably distinguishable over Hori’s disclosed structure.

In “Response to Arguments,” the Examiner has stated that Applicant’s “arguments are not persuasive for the reason that the Applicant’s claim limitations do not specify the position level of the Vss connection region with respect to the source region.” Page 5 , paragraph 7 of the present Office Action. Applicant respectfully disagrees and submits that both independent claims 1 and 8 clearly point out that the Vss connection region is “situated under said bottom of said recess and under said source.” As such, the “position level” of the Vss connection region of the present invention is distinctly defined and pointed out by the independent claims of the present application.

Further, in “Response to Arguments,” the Examiner has also stated that: “Although, it is possible that Hori’s device will not completely eliminate drain induced barrier lowering it will certainly lower it from the highest level developed without the presence of the heavily doped Vss region.” Page 6 of the present Office Action, lines 2-5

Attorney Docket No.: 0180192

(emphasis added). However, as discussed in the present application, according to the presently disclosed and claimed invention, it is not merely the presence of the heavily doped Vss connection region, but it is the position of the heavily doped Vss connection regions, i.e. its position as being fully recessed in relation to the source region, that will reduce the DIBL.

B. Conclusion

For all the foregoing reasons, the present invention as defined by the independent claims, is patentably distinguishable over Hori, either singly or in combination with Kobayashi. Thus, the dependent claims are also patentably distinguishable over Hori, either singly or in combination with Kobayashi. As such, Applicant submits that all remaining claims 1-2, 4-9, and 11-14 are now in condition for allowance and an early Notice of Allowance directed to claims 1-2, 4-9, and 11-14 is respectfully requested.

Attorney Docket No.: 0180192

Respectfully Submitted,
FARJAMI & FARJAMI LLP

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Michael Farjami, Esq.
Reg. No. 38,135

FARJAMI & FARJAMI LLP
26522 La Alameda Ave., Suite 360
Mission Viejo, California 92691
Telephone: (949) 282-1000
Facsimile: (949) 282-1002

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